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Docket No.: 050389-0052

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
 Chihiro KAWAI, et al. : Confirmation Number: 3373
 Application No.: 10/500,975 : Group Art Unit: 2811
 Filed: July 08, 2004 : Examiner: Andrew O. Arena

For: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

PETITION FOR EXTENSION OF TIME

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 Commissioner for Patents
 P.O. Box 1450
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Sir:

Certification of Facsimile Transmission

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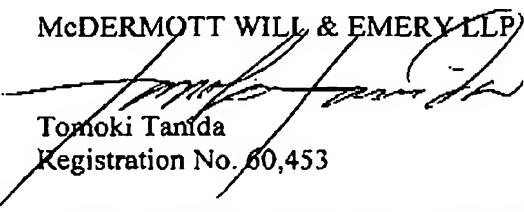
Tomoki Tanida
 Type or print name of person signing certification
Tomoki Tanida 8/1/08
 Signature Date

It is respectfully requested that the time for response to the Office Action dated April 1, 2008, now due to expire July 1, 2008, be extended for one month(s) and set to expire on August 1, 2008.

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP


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08/04/2008 VBUI11 00000016 500417 10500975
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